

Notice of References Cited

Application/Control No.

10/766,465

Applicant(s)/Patent Under

Reexamination

MA ET AL.

Examiner

SU C. KIM

Art Unit

2823

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U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2002/0019099	02-2002	WILLIAMS et al.	438/270
*	B US-2001/0026989	10-2001	Thapar, Naresh	438/400
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
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FOREIGN PATENT DOCUMENTS

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N	JP2000101074		Japan	Uno	
O					
P					
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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